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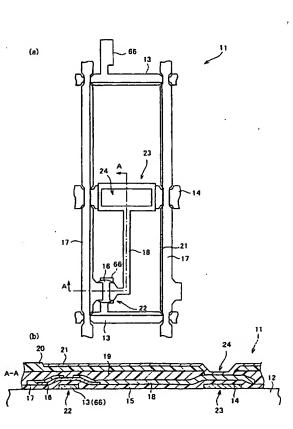
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(54) Title: TFT ARRAY SUBSTRATE, LIQUID CRYSTAL DISPLAY DEVICE, MANUFACTURING METHODS OF TFT ARRAY SUBSTRATE AND LIQUID CRYSTAL DISPLAY DEVICE, AND ELECTRONIC DEVICE



(57) Abstract: A TFT array substrate includes a thin film transistor section in which a gate electrode is formed on a substrate, and a semiconductor layer is formed on the gate electrode via a gate insulation layer. The semiconductor layer of this TFT array substrate has a shape formed by dropping a droplet. Accordingly, it is possible to directly forming a semiconductor layer, or a resist layer for forming the semiconductor layer, by dropping a droplet(s). On this account, the present invention allows the use of an inkjet method, thus reducing costs and numbers of manufacturing processes.

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